



PATENT  
ATTY. DOCKET NO. SAMD/18US3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Strauss et al. Art Unit: 1753  
Serial No. : 08/881,948 Examiner: R. McDonald  
Filed : June 25, 1997  
For : MECHANICALLY JOINED SPUTTERING TARGET AND ADAPTOR  
THEREFOR

Assistant Commissioner of Patents  
Washington, DC 20231

RESPONSE TO OFFICE ACTION

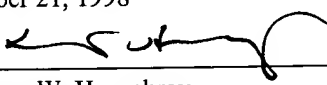
In response to the Examiner's Office Action dated July  
10, 1998, please amend the claims as follows:

9. (Twice Amended) A target for installation in a  
vacuum chamber for processing a substrate by causing sputtering  
material to be ejected from the target onto said substrate,  
comprising

C 1 a [generally] disk-shaped section having two  
[generally] planar surfaces and an outer periphery, said  
[generally] disk-shaped section having at least one radially  
inward step proximate said outer periphery,

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October 21, 1998

  
Thomas W. Humphrey  
Reg. No. 34,353